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ATTORNEY DOCKET NO.: 02887.0271

MAIL STOP PATENT APPLICATION
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

17858 U.S. PTO
10/808298



New U.S. Patent Application

Title: **SEMICONDUCTOR MANUFACTURING APPARATUS AND METHOD OF
MANUFACTURING SEMICONDUCTOR DEVICE**

Inventors and Addresses:

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Sir:

We enclose the following papers for filing in the United States Patent and Trademark Office in connection with the above patent application.

1. Application - 54 pages, including 14 independent claims and 25 claims total.
2. Drawings - 29 sheets of formal drawings containing 122 figures.
3. Certified copy of Japanese Patent Application No. 2003-085376, filed on March 26, 2003.
4. Information Disclosure Statement and Information Disclosure Citation, PTO 1449 with documents attached.
5. The filing fee is calculated as follows:

Basic Application Filing Fee					\$770	\$ 770.00
	Number of Claims		Basic	Extra Claims		
Total Claims	25	-	20	5	x \$18	\$ 90.00
Independent Claims	14	-	3	11	x \$86	\$ 946.00
<input type="checkbox"/> Presentation of Multiple Dep. Claim					+\$290	
Subtotal						\$ 1806.00
Reduction by 1/2 if small entity						-
TOTAL APPLICATION FILING FEE						\$ 1806.00

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6. A check for \$1806.00 is enclosed. The fee includes;

\$770.00 for filing fee; and

\$1036.00 for extra claim fee.

This application is being filed under the provisions of 37 C.F.R. § 1.53(f). Applicants await notification from the Patent and Trademark Office of the time set for filing the Declaration.

Applicants claim the right to priority based on Japanese Patent Application No. 2003-085376, filed on March 26, 2003.

Please address all correspondence with respect to this application to:

**Finnegan, Henderson, Farabow,
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1300 I Street, N.W.
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Please accord this application an application number and filing date.

The Commissioner is hereby authorized to charge any additional filing fees due and any other fees due under 37 C.F.R. § 1.16 or §1.17 during the pendency of this application to our Deposit Account No. 06-0916.

Respectfully submitted,

FINNEGAN, HENDERSON, FARABOW,
GARRETT & DUNNER, L.L.P.

By:


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RVB/FPD/sci
Enclosures

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